



Attorney's Docket No.: 07977-279001 / US5023/5025

07/2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al. Art Unit : 2811
Serial No. : 09/892,225 Examiner : Junghwa M. Im
Filed : June 25, 2001
Title : SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicants call attention to the attached Information Disclosure Statement and documents listed on form PTO-1449.

This filing is being made before the receipt of a first Office action on the merits. No fee is required.

Document AQ is the English-language equivalent of document AL.

Consideration of the foregoing and enclosures plus the return of a copy of the enclosed form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited along with an early action on the merits.

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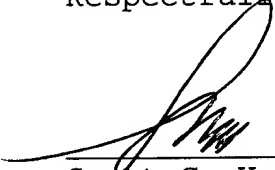
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